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** CONTINUING DATA *****

This application is a CON of 10/214,313 08/08/2002 PAT 6,759,279
 which is a CON of 09/594,046 06/15/2000 PAT 6,448,111
 which is a DIV of 09/126,438 07/30/1998 PAT 6,232,650 *yes, pc*

** FOREIGN APPLICATIONS *****

JAPAN 9-204534 07/30/1997 *yes, pc*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged <i>Carman</i> Examiner's Signature <i>10/21/04</i> Initials	JAPAN	22	7	2

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TITLE
 Method of manufacturing semiconductor device

☐ All Fees